

PROCEEDINGS OF SPIE

Laser Resonators, Microresonators, and Beam Control XVI

Alexis V. Kudryashov
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The CID Number appears on each page of the manuscript. The complete citation is used on the first page, and an abbreviated version on subsequent pages. Numbers in the index correspond to the last two digits of the six-digit CID Number.

Contents

ix *Conference Committee*

MICROCAVITY COMBS

- 8960 02 **Nonlinear dynamics of comb generation in optical microresonators (Invited Paper)** [8960-1]
T. Hansson, D. Modotto, S. Wabnitz, Univ. degli Studi di Brescia (Italy)
- 8960 04 **Two-cycle pulse generation from mode-locked Kerr frequency combs based on an integrated dispersion-flattened micro-resonator (Invited Paper)** [8960-3]
L. Zhang, A. M. Agarwal, L. C. Kimerling, J. Michel, Massachusetts Institute of Technology (United States)
- 8960 05 **Kerr comb generation from the perspective of spatial dissipative structures (Invited Paper)** [8960-4]
A. Coillet, I. Balakireva, K. Saleh, R. Henriët, L. Larger, Y. K. Chembo, FEMTO-ST (France)

NONLINEAR OPTICS WITH MICROCAVITIES

- 8960 07 **Non-Lorentzian pump resonances in whispering gallery optical parametric oscillators** [8960-6]
I. Breunig, A. Bückle, C. S. Werner, Albert-Ludwigs-Univ. Freiburg (Germany); K. Buse, Albert-Ludwigs-Univ. Freiburg (Germany) and Fraunhofer-Institut für Physikalische Messtechnik (Germany)
- 8960 08 **Multicolour emission in silica whispering gallery mode microspherical resonators (Invited Paper)** [8960-7]
D. Farnesi, Museo Storica della Fisica e Ctr. Studi e Ricerche Enrico Fermi (Italy) and Istituto di Fisica Applicata Nello Carrara, CNR (Italy); A. Barucci, S. Berneschi, Istituto di Fisica Applicata Nello Carrara (Italy); G. C. Righini, Museo Storica della Fisica e Ctr. Studi e Ricerche Enrico Fermi (Italy); S. Soria, G. Nunzi Conti, Istituto di Fisica Applicata Nello Carrara (Italy)

MICROCAVITY OPTOMECHANICS

- 8960 0C **Spectral control and temporal properties of resonant optical propulsion of dielectric microspheres in evanescent fiber couplers** [8960-11]
Y. Li, The Univ. of North Carolina at Charlotte (United States); A. V. Maslov, Univ. of Nizhny Novgorod (Russian Federation); V. N. Astratov, The Univ. of North Carolina at Charlotte (United States)
- 8960 0E **Flexible microresonators: lasing and sensing** [8960-13]
V. D. Ta, R. Chen, H. Sun, Nanyang Technological Univ. (Singapore)

MICROCAVITY SENSORS I: GENERAL

- 8960 0F **Challenges in resonant cavity biosensor design: collection efficiency and specificity (Invited Paper)** [8960-14]
A. M. Armani, S. Mehrabani, V. Sun, S. McBirney, R. M. Hawk, E. Gungor, M. Lee, The Univ. of Southern California (United States)
- 8960 0H **Spherical optical microresonator array as a multi-purpose measuring device** [8960-16]
T. Weigel, H. Dobbelstein, C. Esen, G. Schweiger, A. Ostendorf, Ruhr-Univ. Bochum (Germany)
- 8960 0I **Optimization of whispering gallery modes in microbubble resonators for sensing applications** [8960-17]
Y. Yang, J. Ward, S. Nic Chormaic, Okinawa Institute of Science and Technology (Japan)
- 8960 0J **Multi-layered resonators for optimized electric field detection** [8960-18]
T. Ioppolo, V. Ötügen, Southern Methodist Univ. (United States)

MICROCAVITY SENSORS II: BIOSENSING AND PLASMONS

- 8960 0K **Simplified hollow-core microstructural optical fiber laser with intense output and polarized radial emission** [8960-19]
Z.-L. Li, W.-Y. Zhou, Y.-G. Liu, M. Yan, J.-G. Tian, Nankai Univ. (China)
- 8960 0L **Multiphoton excitation of organic chromophores in microbubble resonators** [8960-20]
G. A. Cohoon, K. Kieu, R. A. Norwood, The Univ. of Arizona (United States)
- 8960 0M **High-Q plasmonic bottle microresonator** [8960-21]
M. N. Mohd Nasir, M. Ding, G. S. Murugan, M. N. Zervas, Univ. of Southampton (United Kingdom)
- 8960 0O **Interfacing whispering gallery mode microresonators for environmental biosensing (Invited Paper)** [8960-23]
H. K. Hunt, J. L. Dahmen, C. E. Soteropulos, Univ. of Missouri-Columbia (United States)

MICROCAVITY SENSORS III: ACTIVE SENSORS

- 8960 0S **Optically pumped gold nanorod plasmonic microlaser** [8960-27]
C. Shi, S. Soltani, A. Armani, The Univ. of Southern California (United States)
- 8960 0T **Heterodyning cavity-based microlasers to improve sensing performance** [8960-28]
A. J. Maker, A. M. Armani, The Univ. of Southern California (United States)

BEAM GUIDING, SHAPING, AND ANALYSIS FOR HIGH-POWER APPLICATIONS II: JOINT SESSION WITH CONFERENCES 8960 AND 8963

- 8960 0V **Efficient optical design and measurement technique to six sigma laser processing** [8960-30]
M. Scaggs, G. Haas, Haas Laser Technologies, Inc. (United States)
- 8960 0W **Active wavefront control in Hilase multislabs high-average-power laser system** [8960-31]
J. Pilar, Hilase Project, Institute of Physics of the ASCR, v.v.i. (Czech Republic) and Czech Technical Univ. in Prague (Czech Republic); S. Bonora, Hilase Project, Institute of Physics of the ASCR, v.v.i. (Czech Republic) and LUXOR Lab., CNR (Italy); O. Slezak, M. Divoky, Hilase Project, Institute of Physics of the ASCR, v.v.i. (Czech Republic); M. Sawicka-Chyla, Hilase Project, Institute of Physics of the ASCR, v.v.i. (Czech Republic) and Czech Technical Univ. in Prague (Czech Republic); A. Lucianetti, T. Mocek, Hilase Project, Institute of Physics of the ASCR, v.v.i. (Czech Republic)

MICROCAVITY LASERS AND RF PHOTONICS

- 8960 0X **On phase noise of self-injection locked semiconductor lasers** [8960-32]
E. Dale, W. Liang, D. Eliyahu, A. A. Savchenkov, V. S. Ilchenko, A. B. Matsko, D. Seidel, L. Maleki, OEwaves, Inc. (United States)
- 8960 0Y **Progress towards whispering gallery mode resonator based spectroscopy in mid-infrared (Invited Paper)** [8960-33]
K. Mansour, A. S. Rury, I. S. Grudinin, N. Yu, Jet Propulsion Lab. (United States)
- 8960 0Z **Investigation on high speed directly modulated microcircular lasers (Invited Paper)** [8960-34]
Y.-Z. Huang, X.-M. Lv, L.-X. Zou, H. Long, J.-L. Xiao, Y.-D. Yang, Y. Du, Institute of Semiconductors (China)
- 8960 10 **Spectrally pure RF photonic source based on a resonant optical hyper-parametric oscillator** [8960-35]
W. Liang, D. Eliyahu, A. B. Matsko, V. S. Ilchenko, D. Seidel, L. Maleki, OEwaves, Inc. (United States)

NOVEL MICRORESONATOR TOPOLOGIES AND DEVICES I

- 8960 13 **Crystalline whispering gallery mode resonators: in search of the optimal material** [8960-38]
V. S. Ilchenko, A. A. Savchenkov, A. B. Matsko, L. Maleki, OEwaves, Inc. (United States)
- 8960 15 **Droplet resonator based optofluidic microlasers (Invited Paper)** [8960-40]
A. Kiraz, Koç Univ. (Turkey); A. Jonáš, Istanbul Technical Univ. (Turkey); M. Aas, Y. Karadag, Koç Univ. (Turkey); O. Brzobohatý, J. Ježek, Z. Pilát, P. Zemánek, Institute of Scientific Instruments of the ASCR, v.v.i. (Czech Republic); S. Anand, D. McGloin, Univ. of Dundee (United Kingdom)

NOVEL MICRORESONATOR TOPOLOGIES AND DEVICES II

- 8960 16 **Self-assembled liquid-crystal microlasers, microresonators, and microfibres (Invited Paper)** [8960-41]
I. Muševič, Jožef Stefan Institute (Slovenia); H. Peng, Univ. of Ljubljana (Slovenia); M. Nikkhou, M. Humar, Jožef Stefan Institute (Slovenia)
- 8960 17 **Whispering-gallery modes excitation in microspheres integrated inside microstructured optical fibers (Invited Paper)** [8960-42]
K. Kosma, G. Zito, Foundation for Research and Technology-Hellas (Greece); K. Schuster, Institut für Photonische Technologien e.V. (Germany); S. Pissadakis, Foundation for Research and Technology-Hellas (Greece)
- 8960 18 **Optical microstub resonator lasers** [8960-43]
G. S. Murugan, S. Bakhtiari-Gorajoobi, C. A. Codemard, M. N. Mohd Nasir, G. Y. Chen, Univ. of Southampton (United Kingdom); A. Langner, Heraeus Quarzglas GmbH & Co. KG (Germany); M. N. Zervas, Univ. of Southampton (United Kingdom)
- 8960 1A **Fabrication of optical cavities with femtosecond laser pulses** [8960-45]
J. Lin, J. Song, J. Tang, Shanghai Institute of Optics and Fine Mechanics (China); W. Fang, Zhejiang Univ. (China); K. Sugioka, RIKEN (Japan); Y. Cheng, Shanghai Institute of Optics and Fine Mechanics (China)

PULSED LASERS

- 8960 1D **26ps pulses from a passively Q-switched microchip laser** [8960-48]
B. Bernard, Nuremberg Institute of Technology Georg Simon Ohm (Germany); E. Mehner, Nuremberg Institute of Technology Georg Simon Ohm (Germany) and Univ. Stuttgart (Germany); D. Kopf, MONTFORT Laser GmbH (Austria); H. W. Giessen, Univ. Stuttgart (Germany); B. Braun, Nuremberg Institute of Technology Georg Simon Ohm (Germany)

COUPLED RESONATORS, BEAM COMBINING, AND ADAPTIVE OPTICS

- 8960 1E **Nonlinear effects in coherently coupled laser resonators (Invited Paper)** [8960-49]
J. R. Leger, H.-S. Chiang, Univ. of Minnesota (United States)
- 8960 1F **Simultaneous laser beam combining and mode conversion using multiplexed volume phase elements** [8960-50]
M. SeGall, I. Divliansky, C. Jollivet, A. Schülzgen, L. Glebov, CREOL, The College of Optics and Photonics, Univ. of Central Florida (United States)
- 8960 1G **Wide aperture (more than 500 mm) deformable mirrors for high power laser beam correction** [8960-51]
A. Kudryashov, V. Samarkin, A. Alexandrov, J. Sheldakova, P. Romanov, Moscow State Open Univ. (Russian Federation)

BEAM SHAPING I

- 8960 1H **Intra-cavity metamorphosis of a Gaussian beam to flat-top distribution** [8960-52]
D. Naidoo, Council for Scientific and Industrial Research (South Africa) and Univ. of Stellenbosch (South Africa); I. Litvin, Council for Scientific and Industrial Research (South Africa); A. Laskin, AdlOptica Optical Systems GmbH (Germany); A. Forbes, Council for Scientific and Industrial Research (South Africa) and Univ. of Stellenbosch (South Africa)

BEAM SHAPING II

- 8960 1K **The digital laser: on-demand laser modes with the click of a button (Invited Paper)** [8960-55]
A. Forbes, S. Ngcobo, Council for Scientific and Industrial Research (South Africa) and Univ. of KwaZulu-Natal (South Africa); L. Burger, I. A. Litvin, Council for Scientific and Industrial Research (South Africa)
- 8960 1L **Tuneable Gaussian to flat-top resonator by amplitude beam shaping using a digital laser** [8960-56]
S. Ngcobo, Council for Scientific and Industrial Research (South Africa) and Univ. of KwaZulu-Natal (South Africa); K. Ait-Ameur, ENSICAEN (France); I. Litvin, Council for Scientific and Industrial Research (South Africa); A. Hasnaoui, Univ. des Science et de la Technologie Houari Boumediene (Algeria); A. Forbes, Council for Scientific and Industrial Research (South Africa) and Univ. of KwaZulu-Natal (South Africa)
- 8960 1N **Beam shaping with a laser amplifier** [8960-58]
I. A. Litvin, O. J. P. Collett, Council for Scientific and Industrial Research (South Africa)
- 8960 1O **Engineering of automated assembly of beam-shaping optics** [8960-59]
S. Haag, Fraunhofer-Institut für Produktionstechnologie (Germany); V. Sinhoff, INGENERIC GmbH (Germany); T. Müller, C. Brecher, Fraunhofer-Institut für Produktionstechnologie (Germany)

BEAM SHAPING III

- 8960 1P **Freeform beam shaping for high-power multimode lasers** [8960-60]
A. Laskin, V. Laskin, AdlOptica Optical Systems GmbH (Germany)
- 8960 1Q **Laser beams with conical refraction patterns** [8960-61]
Y. V. Loiko, Univ. of Dundee (United Kingdom); G. S. Sokolovskii, Ioffe Physico-Technical Institute (Russian Federation), Univ. of Dundee (United Kingdom), and Petersburg State Electrotechnical Univ. "LETI" (Russian Federation); D. Carnegie, Univ. of Dundee (United Kingdom); A. Turpin, J. Mompert, Univ. Autònoma de Barcelona (Spain); E. U. Rafailov, Univ. of Dundee (United Kingdom)
- 8960 1R **Diffraction limited focal spot in the interaction chamber using phase retrieval adaptive optics** [8960-62]
N. Lefaudeux, E. Lavergne, Imagine Optic SA (France); S. Monchoce, CEA Saclay (France); X. Levecq, Imagine Optic SA (France)

- 8960 1S **Reduction of speckle contrast in multimode fibers using piezoelectric vibrator** [8960-63]
Y. Fujimaki, H. Taniguchi, Mitsubishi Cable Industries, Ltd. (Japan)
- 8960 1T **Stability of a laser cavity with non-parabolic phase transformation elements and applications** [8960-64]
I. A. Litvin, Council for Scientific and Industrial Research (South Africa)

POSTER SESSION

- 8960 1V **Investigation of the low power stage of an 1178nm Raman system** [8960-66]
L. J. Henry, Air Force Research Lab. (United States); M. Klopfer, The Univ. of New Mexico (United States); C. Mart, Univ. of Arizona (United States); J. Grosek, Air Force Research Lab. (United States); R. Jain, The Univ. of New Mexico (United States)
- 8960 1W **Liquid core microbubble resonators for highly sensitive temperature sensing** [8960-67]
J. M. Ward, Y. Yang, S. Nic Chormaic, Okinawa Institute of Science and Technology (Japan)
- 8960 1X **Digital control of laser modes with an intra-cavity spatial light modulator** [8960-68]
S. Ngcobo, Council for Scientific and Industrial Research (South Africa) and Univ. of KwaZulu-Natal (South Africa); I. Litvin, L. Burger, Council for Scientific and Industrial Research (South Africa); A. Forbes, Council for Scientific and Industrial Research (South Africa) and Univ. of KwaZulu-Natal (South Africa)
- 8960 1Y **Optimized Findlay-Clay analysis for diode side-pumped Nd:YAG lasers** [8960-69]
A. Farhoodfar, San Jose City College (United States) and International Technological Univ. (United States); S. Sukuta, San Jose City College (United States)
- 8960 1Z **Stable ring resonator with bidirectional passes through the gain medium** [8960-70]
A. H. Paxton, H. C. Miller, Air Force Research Lab. (United States)

Author Index

Conference Committee

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Feinmechanik (Germany) and Friedrich-Schiller-Universität Jena
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(United States)
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Lan Yang, Washington University in St. Louis (United States)

Session Chairs

- 1 Microcavity Combs
Vladimir S. Ilchenko, OEwaves, Inc. (United States)
- 2 Nonlinear Optics with Microcavities
Andrey B. Matsko, OEwaves, Inc. (United States)
- 3 Microcavity Optomechanics
Andrea M. Armani, The University of Southern California
(United States)
- 4 Microcavity Sensors I: General
Sahin Kaya Ozdemir, Washington University in St. Louis (United States)
- 5 Microcavity Sensors II: Biosensing and Plasmons
Nan Yu, Jet Propulsion Laboratory (United States)
- 6 Microcavity Sensors III: Active Sensors
Andrew Forbes, CSIR National Laser Center (South Africa)
- 7 Beam Guiding, Shaping, and Analysis for High-Power Applications I:
Joint Session with Conferences 8960 and 8963
Friedhelm Dorsch, TRUMPF Werkzeugmaschinen GmbH + Co. KG
(Germany)
- 8 Beam Guiding, Shaping, and Analysis for High-Power Applications II:
Joint Session with Conferences 8960 and 8963
Lutz Aschke, LIMO Lissotschenko Mikrooptik GmbH (Germany)
- 9 Microcavity Lasers and RF Photonics
Yanne K. Chembo, FEMTO-ST (France)
- 10 Novel Microresonator Topologies and Devices I
Gualtiero Nunzi Conti, Istituto di Fisica Applicata Nello Carrara (Italy)
- 11 Novel Microresonator Topologies and Devices II
Vladimir S. Ilchenko, OEwaves, Inc. (United States)

- 12 Pulsed Lasers
James R. Leger, University of Minnesota, Twin Cities (United States)
- 13 Coupled Resonators, Beam Combining, and Adaptive Optics
Alan H. Paxton, Air Force Research Lab. (United States)
- 14 Beam Shaping I
Kunihiko Washio, Paradigm Laser Research Ltd. (Japan)
- 15 Beam Shaping II
Jean-Claude M. Diels, The University of New Mexico (United States)
- 16 Beam Shaping III
Alexis V. Kudryashov, Moscow State Open University
(Russian Federation)

